



Docket No.: 4887P578

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of:

MARK N. KAWAGUCHI ET AL.

Application No.: 09/978,121

Filed: October 15, 2001

For: **A METHOD OF PHOTORESIST REMOVAL IN
THE PRESENCE OF A DIELECTRIC LAYER
HAVING A LOW K-VALUE**

Art Group: 1763

Examiner: Olsen, Allan W.

PETITION FOR EXTENSION OF TIME PURSUANT TO 37 C.F.R. § 1.136(a)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

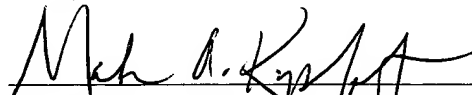
In accordance with 37 C.F. R. § 1.136(a), Applicant for the above-identified application respectfully Petitions the Commissioner for a one (1) month extension of time, extending the period for response to April 07, 2005, from the Office Action dated December 07, 2004. The petition filing fee of \$120.00 and a Request for Continued Examination (RCE) are attached.

If it should be determined that a longer extension of time is required to prevent this application from being abandoned, please charge any additional fees to Deposit Account No. 02-2666. A copy of the Fee Transmittal is enclosed for deposit account charging purposes.

Respectfully submitted,

Blakely, Sokoloff, Taylor & Zafman LLP

Date: April 07, 2005


Mark A. Kupanoff, Reg. No. 53,349

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CERTIFICATE OF MAILING/TRANSMISSION

I hereby certify that this correspondence is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to: Mail Stop RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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120.00 OP


Esther L. Campbell

04-07-05
Date